

32784US4

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FILING DATE:

GROUP ART UNIT:

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass	Filing Date If Appropriate
	A	5,487,012	1/1996	Topholm et al.			10/94
	B	5,068,902	11/1991	Ward			3/1989
	C	5,056,204	10/1991	Bartschi			5/1990
	D	5,641,448	6/1997	Yeung et al.			
	E	4,984,277	1/1991	Bisgaard et al.			
	F	5,979,589	11/1999	Aceti			
	G	4,091,067	5/1978	Kramer et al.			
	H	6,495,214	12/2002	Prix et al.			
	I						
	J						
	K						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation
	L	0 516 808 B1	1/1996	EP			Claims Only
	M	00/34739	6/2000	WO			Cited in ISR
	N	0 010 200 A	3/1998	BE			Cited in ISR
	Q						

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>SWA</i>	R	Article: "The Selective Laser Sintering Process Third Generation Desk Top Manufacturing," DTM Corporation, 6/4/1990
	S	
	T	

Examiner:

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Date Considered

10/28/04

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